

Search Notes

Application/Control No.

10/813,929

Examiner

John Rivell

Applicant(s)/Patent under
Reexamination

KAYUKAWA, HISASHI

Art Unit

3753

SEARCHED

Class	Subclass	Date	Examiner
137	223 234.5 375 454.5 541	7/17/2006	
152	415 427 429	7/17/2006	
152	Dig. 11	7/17/2006	

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
None	7/17/2006	